PTO/SB/08a (08-03)

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(Use as many sheets as necessary Attorney Docket Number 040258-0307826 of Sheet

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			Application Number		
INFORM	MATION L	DISCLOSURE	Filing Date	01/23/2004	
STATE	STATEMENT BY APPLICANT		First Named Inventor	TADAHIRO OHMI	
			Art Unit	2818	<u> </u>
(Use as many sheets as necessary)			Examiner Name		
Sheet		of 1	Altorney Docket Number	040258-0307826	

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), votume-issue number(s), publisher, city and/or country where published.	T²		
NB	1	ITO ET AL., "Silicon Oxynitridation With Inductively Coupled Oxygen-Nitrogen Mixed Plasma," Jpn. J. Appl. Phys., p. 612-616, (1997).			
M	2	HIRAYAMA ET AL., "Low-Temperature Growth of High-Integrity Silicon Oxide Films by Oxygen Radical Generated in High-Density Krypton-Plasma," IEEE, p. 249-252, (1999).			
NB	3	SAITO ET AL., "Low Temperature Formation of Gate-Grade Silicon Nitride Film Employin Microwave-Excitation High-Density Plamsa," Technical Report, IEICE, p. 85-90, (1999).	3		
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